Application Number:	10694986							
Filing Date:	29	29-Oct-2003						
Title of Invention:	Me se	Method for removing resist pattern and method for manufacturing semiconductor device						
First Named Inventor/Applicant Name:	Masaharu Nagai							
Filer:	Dia	Diana DiBerardino						
Attorney Docket Number:	12	12732-171001						
Filed as Large Entity	·							
Utility Filing Fees								
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:	_							
Pages:								
Claims:								
Claims in excess of 20		1202	8	50	400			
Miscellaneous-Filing:								
Petition:								
Patent-Appeals-and-Interference:								
Post-Allowance-and-Post-Issuance:								

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 1 month with \$0 paid	1251	1	120	120
Miscellaneous:				
	Tota	520		